

Electronic Patent Application Fee Transmittal

Application Number:	10606512			
Filing Date:	26-Jun-2003			
Title of Invention:	Method for cleaning a processing chamber and method for manufacturing a semiconductor device			
First Named Inventor/Applicant Name:	Jung-Wook Kim			
Filer:	Frank Chau			
Attorney Docket Number:	8054-23 (AW8037US/JJ)			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				790